## NOTES:

- SUBSTRATE: Fused Silica
- 2. SURFACE \$1 TO BE PARALLEL TO SURFACE \$2 TO WITHIN <3 ARCMINS
- 3. COATING (APPLY ACROSS COATING APERTURE)

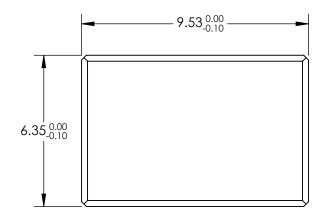
\$1: R(AB\$) >99.8% @ 355nm R(AB\$) >99.5% @ 351 - 358nm DAMAGE THRESHOLD, PULSED: 6 J/cm<sup>2</sup> @ 355nm, 20ns, 20Hz CW: 1 MW/cm<sup>2</sup> @ 355nm

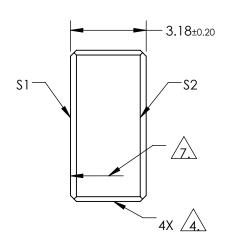
S2: NONE

4.\ FINE GROUND SURFACE

- 5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
- 6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE

ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS TOWARDS SURFACE S1  $\,$ 





## PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

	\$1	S2					
SHAPE	PLANO	PLANO				Edmund Optic	C®
SURFACE QUALITY	10-5	COMMERCIAL POLISH					· <b>5</b>
SURFACE FLATNESS	0.10 WAVE	N/A		1		6.35 x 9.53mm 355nm 45°, Nd:YAG Lasei	rline
MIN CLEAR APERTURE	5.40 x 8.10	N/A	THIRD ANGLE PROJECTION		TITLE	Mirror	LIIIC
MIN COATNG APERTURE	5.40 x 8.10	N/A					CLIEFT
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	39615	SHEET 1 OF 1